

Title (en)  
PROCESS FOR PRODUCING POLYCRYSTALLINE SILICON

Title (de)  
VERFAHREN ZUR HERSTELLUNG VON POLYKRISTALLINEM SILICIUM

Title (fr)  
PROCÉDÉ DE PRODUCTION DE SILICIUM POLYCRISTALLIN

Publication  
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Application  
**EP 14786183 A 20141017**

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Abstract (en)  
[origin: WO2015062880A1] The invention relates to a method for producing polycrystalline silicon, comprising a deposition of polycrystalline silicon on a carrier body in order to obtain a polycrystalline silicon rod, or a deposition of polycrystalline silicon on silicon particles in order to obtain polycrystalline silicon granules, wherein each deposition takes place in a reactor located in a class 1-100 000 cleanroom into which filtered air is directed. For filtration, said air first passes through at least one filter that removes particles greater than or equal to 1 µm, and subsequently passes through a HEPA filter that removes particles smaller than 1 µm.

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